



272018

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q78681

Takayasu YAMAMOTO, et al.

Appln. No.: 10/721,381

Group Art Unit: 2877

Confirmation No.: 6006

Examiner: Sang H. NGUYEN

Filed: November 26, 2003

For: INSPECTING DEVICE FOR SEMICONDUCTOR WAFER

**PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.136, Applicant hereby petitions for an extension of time of three (3) months, extending the time for responding to the Office Action of June 17, 2004 to December 17, 2004.

A check for the statutory fee of \$1020.00 is attached. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this sheet is enclosed.

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WASHINGTON OFFICE

**23373**

CUSTOMER NUMBER

Respectfully submitted,

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Date: December 17, 2004